Customer No.: 31561 Docket No.: 10026-US-PA-0C

Docket No.: 10026-US-PA-00 Application No.: 10/711,664

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:)
Li-Hsien Yen	Examiner: LAM, CATHY FONG FONG
Serial No.: 10/711,664) Art Unit: 1775
Filed: September 30, 2004) Docket No.: 10026-US-PA-0C
For: MULTILAYER STRUCTURE FO MANUFACTURING METHOD THER	R ABSORBING FLECTROMAGNATIC WAVE AND EOF)

No fee is believed to be due in connection with this amendment and response to Office Action. If, however, any fee is believed to be due, the Commission er is authorized to charge any fees required in connection with the filing of this paper to account No. 50-2620 (order No. 10026-US-PA-0C).

AMENDMENT AND RESPONSE TO OFFICE ACTION

United States Patent and Trademark Office Customer Service Window Mail Stop <u>Amendment</u> Randolph Building 401 Dulany Street Alexandria, VA 22314

Sir:

The Office Action mailed 12/09/2004 has been carefully considered. In response thereto, please enter the following amendments and consider the following remarks.